

Applied Materials Mirra 3400 Chemical Mechanical Polishing (CMP), 6"

Asset ID: 38536

Configuration Details:

Applied Materials Mirra 3400 Chemical Mechanical Polishing (CMP), 6"

- DIWO (Dry-in wet-out)
- Silicon Oxide, Polyimide, a-Si
- 208 V, 200 A, 45 kVA, Standby 6,5 kVA
 1996 Vintage



See Photos on Following Pages

To our knowledge, the information contained in this data sheet is accurate, but it may contain errors and we do not warrant the completeness or accuracy of this data.

Interested parties may contact Bridge Tronic Global for additional information at +1 949.396.1395 or sales@bridgetronic.com

Visit our website at: www.bridgetronic.com



QUICK LEAD TIMES



QUALITY



COMPETITIVE PRICING



Polisher Work Station

























Polisher Robot Fabs Module



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COMPETITIVE PRICING



Polisher













Polisher Cover













Polisher Spindel Head 1 and 2













Polisher pl1 - Slurry Check













Polisher / Head Over pl3













Polisher HCLU





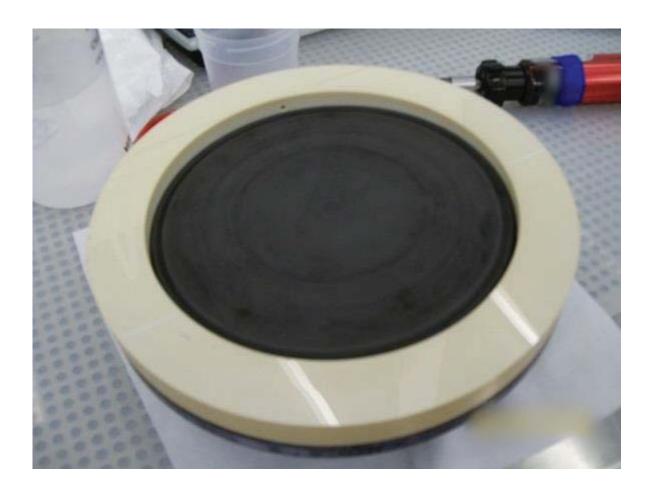








Two heads Titan II included













E-Rack



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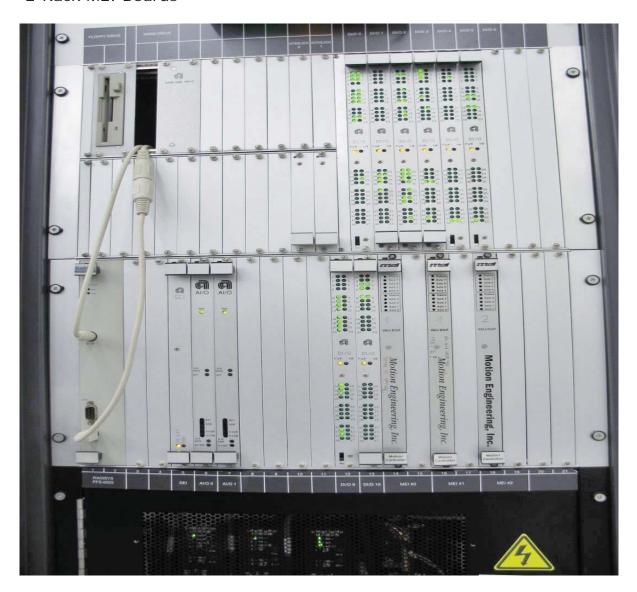




COMPETITIVE PRICING



E-Rack MEI Boards













Polisher Intern Facility

